Searching PAJ

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Applicant, Title of invention, Abstract — e.g. computer semiconductor						
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	AND					
piezoelectric		AND -				
\$	AND					
electrode		AND 🕶				
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Searching PCT (Full Text)...

[Search Summary]

Results of searching in PCT (Full Text) for: titanium near substrate and electrode and (piezoelectric or "piezoelectric/electrostrictive"): 0 records

Refine Search titanium near substrate and electrode and (piezoelect

No records matching your query found in PCT (Full Text)

Search Summary

titanium NEAR substrate: 0 occurrences in 0 records.

electrode: 993877 occurrences in 42664 records. (titanium NEAR substrate AND electrode): 0 records.

piezoelectric: 92632 occurrences in 10876 records.

PIEZOELECTRIC/electrostrictive: 1774 occurrences in 397 records. (piezoelectric OR PIEZOELECTRIC/electrostrictive): 10947 records. ((titanium NEAR substrate AND electrode) AND (piezoelectric OR

PIEZOELECTRIC/electrostrictive)): 0 records.

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Search Results 02/11/2005 - 12:18:31

Search Query :
(((((substrate <and> titanium)) <ané

Query: (((((substrate <and> titanium)) <and> ((electrode <or> electrodes)) <and> ((piezoelectric or "piezoelectric/electrostrictive"))) <in> claims))

9 documents out of 1622198 matched your query. Click on its number to view the details of the document.

Note: All document detail pages now appear on a new Browser Window.

1. 2438360 PIEZOELECTRIC ELEMENT, INK JET HEAD, 100% ANGULAR VELOCITY SENSOR, MANUFACTURING METHOD THEREOF, AND INK JET TYPE RECORDING APPARATUS

2. 2351199 STRUCTURE OF PIEZOELECTRIC 100% ELEMENT AND LIQUID DISCHARGE RECORDING HEAD, AND METHOD OF MANUFACTURE THEREFOR

3. 2163033 A FILM BULK ACOUSTIC WAVE DEVICE 100%

4. 1255139 OPTICAL FREQUENCY CONVERTER 100%
DEVICE AND A RATE GYRO CONTAINING
SUCH A DEVICE

5. 2202062 MICRO-MINIATURE PIEZOELECTRIC 99%
DIAPHRAGM PUMP FOR THE LOW
PRESSURE PUMPING OF GASES

6. 2191132 THIN FILM ACTUATED MIRROR ARRAY 98% FOR USE IN AN OPTICAL PROJECTION SYSTEM AND METHOD FOR THE

	Туре	L #	Hits	Search Text	DBs
1	BRS	L1	4939	titanium and (piezoelectric or electrostrictive or "piezoelectric/electrostric tive")	USPAT
2	BRS	L2	401	titanium same substrate and (piezoelectric or electrostrictive or "piezoelectric/electrostric tive") same electrode\$1	USPAT
3	BRS	L3	193	titanium.clm. and substrate and (piezoelectric or electrostrictive or "piezoelectric/electrostric tive") same electrode\$1	USPAT
4	BRS	L4	121	<pre>(titanium and substrate).clm. and (piezoelectric or electrostrictive or "piezoelectric/electrostric tive") same electrode\$1</pre>	USPAT
5	BRS	L5	43	(titanium same substrate).clm. and (piezoelectric or electrostrictive or "piezoelectric/electrostric tive") same electrode\$1	USPAT
6	BRS	L6	30	(titanium same substrate).clm. and (piezoelectric or electrostrictive or "piezoelectric/electrostric tive") same electrode\$1	US- PGPUB; USOCR
7	BRS	L7	93	(titanium same substrate) and (piezoelectric or electrostrictive or "piezoelectric/electrostric tive") same electrode\$1	EPO; JPO; DERWEN T; IBM_TD B